

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10577916	
	Filing Date		2006-05-01	
	First Named Inventor	Ryoji FUNAHASHI		
	Art Unit			
	Examiner Name	Not yet assigned		
	Attorney Docket Number		062440	

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	4	2003-282964	JP	A	2003-10-03	NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL & TECH..		<input checked="" type="checkbox"/>
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	1	R. Chiba et al. "Properties of La1-ySryNi-xFexO3 as a cathode material for a low-temperature operating SOFC", Solid State Ionics, Vol. 152-153, pages 575 to 582 (2002)	<input type="checkbox"/>
	2	E. Rodriguez, et al. "Structural Electronic and Magnetic Characterization of the Perovskite LaNi1-xO3...", Journal of Materials Chemistry, Vol.148, pages 479 to 486 (1999)	<input type="checkbox"/>
	3	P. Odier et al., "Sol-gel synthesis and structural characterization of the perovskite type pseudo solid solution LaNi0.5Cu0.5O3", Journal of Materials Chemistry, Vol.12, pages 1370 to 1373 (2000)	<input type="checkbox"/>

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4	R. Funahashi et al., "Thermoelectric properties of Ln-Ni-O (Ln : lanthanoid) system", 22nd International Conference on Thermoelectric, pages 184 to 187 (2003)	<input type="checkbox"/>
5	R. Funahashi et al, "Exploration of n-type oxides by high throughput screening", Applied Surface Science, Vol.223, pages 44 to 48 (2004)	<input type="checkbox"/>
6	R. Furuhashi et al., "High-throughput screening of thermoelectric oxides and power generation modules consisting of oxide uncouples", Measurement Science and Technology, Vol.15, pages 1 to 11 (2004)	<input type="checkbox"/>
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☐ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

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☐ See attached certification statement.

☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.

☐ None

**SIGNATURE**

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/William F. Westarman/	Date (YYYY-MM-DD)	2006-08-01
Name/Print	William F. Westerman	Registration Number	29988

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